

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/533,462	MAYERESSE, YVES
	<b>Examiner</b> Rodney P. Swartz, Ph.D.	<b>Art Unit</b> 1645

<b>INTERFERENCE SEARCHED</b>			
Class	Subclass	Date	Examiner